



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|--|---|---|
| Applicant: | Hyoung June KIM |) | Examiner: Quang T. Van |
| Serial No.: | 09/886,940 |) | Art Unit: 3742 |
| Filed: | June 21, 2001 |) | Our Ref: B-4227 618899-5/MSG/RP |
| For: | METHODS & APPARATUSES FOR HEAT TREATMENT OF SEMICONDUCTOR FILMS UPON THERMALLY SUSCEPTIBLE NON- CONDUCTING SUBSTRATES |) | Date: May 25, 2004 |
| | |) | Re: <i>Request for Continued Examination</i> |

AMENDMENT AND RESPONSE

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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JUN 03 2004

TECHNOLOGY CENTER R3700

Sir:

In reply to the final Office Action mailed on February 25, 2004, an initial response to which is due no later than **May 25, 2004**, Applicant submits this paper together with a Request for Continued Examination (RCE) pursuant to 37 C.F.R. 1.114 and a check in the amount of \$385.00 for the fee set forth in 37 C.F.R. 1.17(e). Please amend the above-identified application as described below and consider the following remarks. **All amendments and remarks herein are made without prejudice.**

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.